

FORM PTO-1449				Docket Number (Optional) 153A 3535		Application Number 10/798490	
INFORMATION DISCLOSURE CITATION IN AN APPLICATION				Applicant Amano et al.			
(Use several sheets if necessary)				Filing Date 3/11/2004		Group Art Unit 2975 - Leah Lovell	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION (YES/NO)	
lsl	JP 2002-184212	6/28/2002	Japan	—	—		
lsl	JP 2001-283616	10/12/2001	Japan	—	—		
lsl	JP 2002-109907	4/12/2002	Japan	—	—		
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER Leah Lovell	DATE CONSIDERED 8 NOV 2005						
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							